

# FRictional BEHAVIOR OF SYNTHETIC MOLYBDENUM DISULFIDE IN HIGH VACUUM

高真空中における合成二硫化モリブデンの摩擦特性

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## 1. Introduction

One of the authors (M. M.) studied on friction of molybdenum disulfide in high vacuum and got a result that the steady-state coefficient of friction\*\* ( $\mu_k$ ) of molybdenum disulfide ( $\text{MoS}_2$ ) in high vacuum is the lowest as compared with that in low vacuum and in air. He and his co-workers discussed the frictional behavior of  $\text{MoS}_2$  according to the above assumption. They confirmed in their experiments that  $\mu_k$  was high at the initial stage of sliding and that it decreased to a lower value when the friction test was continued in high vacuum<sup>1)</sup>. After  $\mu_k$  decreased to a lower value in high vacuum,  $\mu_k$  did not rise under  $10^{-2}$  Torr and there was a marked rise in  $\mu_k$  at about  $10^{-2}$  Torr when the air was introduced. The result is shown in Fig. 1.

However, it is natural to consider that  $\mu_k$  in the absolutely clean  $\text{MoS}_2$  surface will not be the lowest, that  $\mu_k$  in  $\text{MoS}_2$  slightly absorbed vapors will be the lowest, and that moist air rises the

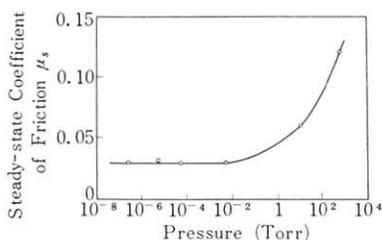


Fig. 1 Effect of pressure on the coefficient of friction of  $\text{MoS}_2$ .

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\*\* In this report,  $\mu$  denotes coefficient of friction in general,  $\mu_k$  that of steady-state and  $\mu_i$  that of initial stage after stopping.

friction to a high value. Haltner<sup>2)</sup> and Jamison<sup>3)</sup> reported the phenomenon after their experiments and Tsuya also believes the theory<sup>4)</sup>. By these considerations, the lowest friction at high vacuum as shown in Fig. 1 would be due to the contamination remained on the surface layer. In this report, it will be described that above-mentioned results are obtained in synthetic  $\text{MoS}_2$  in authors' experiments.

## 2. Experimental methods

### 1) Specimens

The synthetic  $\text{MoS}_2$  used was proprietary and was deposited on copper specimen by electrophoretic coating at the voltage of 500 V/cm in acetone containing  $\text{MoS}_2$  2g/l. The thickness of  $\text{MoS}_2$  film was 1  $\mu\text{m}$  after 10 minute's deposition. The coated  $\text{MoS}_2$  is shown in Fig. 2 by electron-microscopy.

### 2) Friction apparatus

Friction apparatus was described in the previous report<sup>1)</sup>, the load on specimen was 200 g, and the upper slider was a steel ball plated with copper. The other conditions were the same as the previous report<sup>1)</sup>.

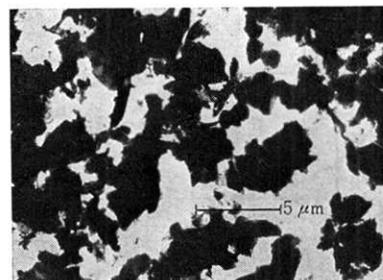


Fig. 2 Electronmicroscopy of synthetic  $\text{MoS}_2$  used.

### 3. Experimental results

#### 1) Effect of atmospheric pressure on $\mu_k$

Fig. 3 indicates the effect of atmospheric pressure on  $\mu_k$  and the electrical contact resistance when the room air was introduced in the vacuum system. It is shown that the minimum  $\mu_k$  occurs at the range of  $10^{-2}$  Torr. These results coincide with Haltner's<sup>2)</sup>. It is interesting that the electrical contact resistance curves have nearly the same pattern as  $\mu_k$ . The cause is not clear now.

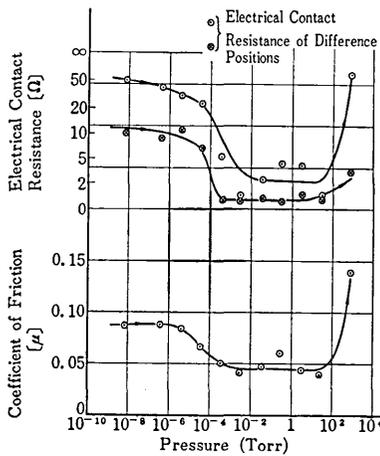


Fig. 3 Effect of atmospheric pressure on  $\mu_k$  and the electrical contact resistance.

#### 2) Stop time effect

The stop time effect on  $\mu_k$  and the electrical contact resistance was measured. It was postulated from the previous report<sup>1)</sup> that the stop time effect was originated from the vapor absorption on the surface during stopping. Examples of re-

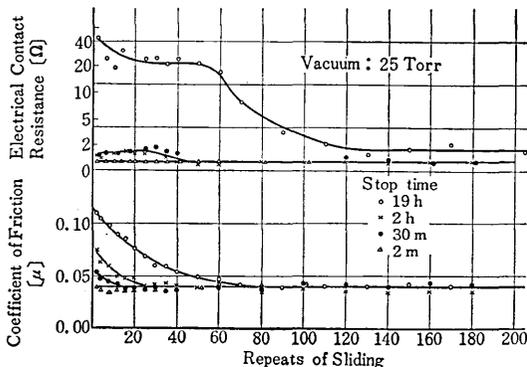


Fig. 4 Stop time effect at 25 Torr

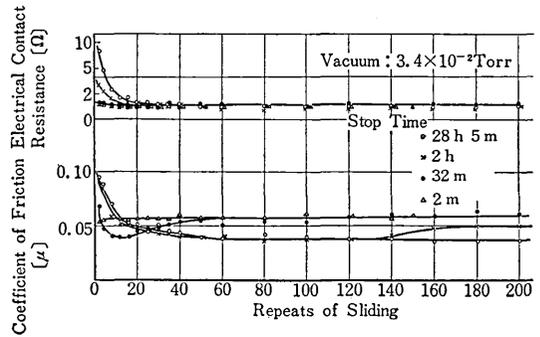


Fig. 5 Stop time effect at  $3.4 \times 10^{-2}$  Torr.

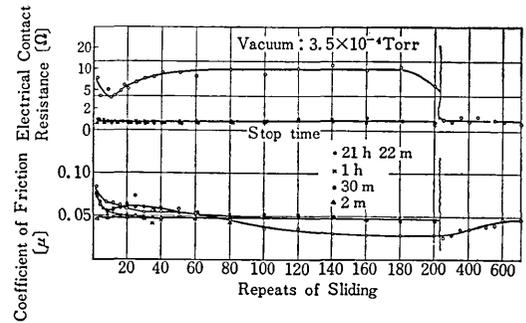


Fig. 6 Stop time effect at  $3.5 \times 10^{-4}$  Torr.

sults in the synthetic  $\text{MoS}_2$  are shown in Figs. 4 to 9. In the minimum  $\mu_k$  range,  $\mu_i$  rose during stopping indicating  $\mu_k$  at higher atmospheric pressure. The higher the pressure, the higher  $\mu_i$  was obtained as anticipated and these results are shown in Figs, 4, 5 and 6.

In the high vacuum and higher  $\mu_k$  range,  $\mu_i$  decreased during stopping, indicating also  $\mu_k$  at higher atmospheric pressure where  $\mu_k$  is lower. At extremely high vacuum, the decrease was not prominent as shown in Fig. 9. However, at  $3.5 \times 10^{-5}$  Torr, boundary of the high and low  $\mu_k$ ,

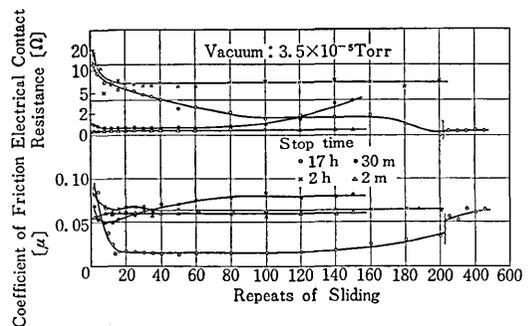


Fig. 7 Stop time effect at  $3.5 \times 10^{-5}$  Torr.

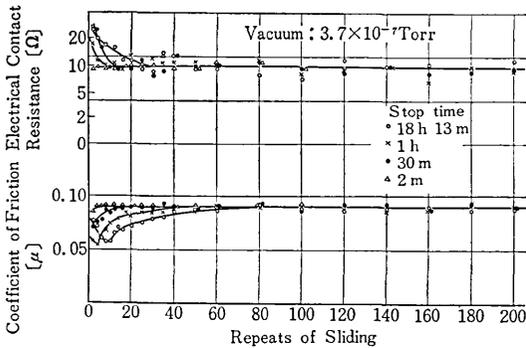


Fig. 8 Stop time effect at  $3.7 \times 10^{-7}$  Torr.

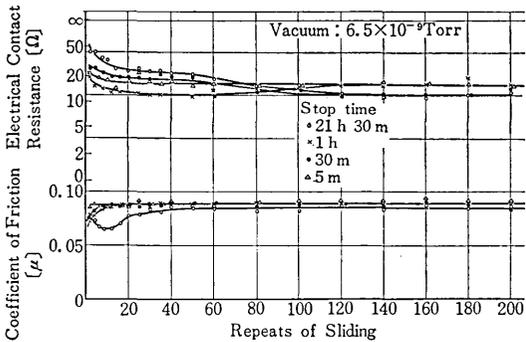


Fig. 9 Stop time effect at  $6.5 \times 10^{-9}$  Torr.

the decrease was prominent, especially after a long stop time, as shown in Fig. 7. This fact showed that the surface layer of MoS<sub>2</sub> with slightly absorbed vapors had the minimum  $\mu_k$ .

#### 4. Conclusions

From these experiments, following conclusions

are derived,

1)  $\mu_k$  on the extremely clean surface of synthetic MoS<sub>2</sub> is higher than that on the surface which absorbed vapor slightly.

2) It is not clear whether the only synthetic MoS<sub>2</sub> has the above-mentioned frictional characteristics or natural MoS<sub>2</sub> also has the same one.

3) As the minimum  $\mu_k$  range,  $\mu_i$  rises after stopping, and at the higher vacuum and higher  $\mu_k$  range,  $\mu_i$  decreases after stopping. This phenomena can be explained by vapor absorption theory.

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#### References

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